



205-28-1

Image 2899

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
SUNGHO JIN ET AL. )  
Application No.: 10/141,421 )  
Filed: 01/22/2002 )  
For: Optical Systems Comprising Curved )  
MEMs Mirrors and Methods for Making )  
Same )  
Examiner: Mooney, Michael P.  
Group Art Unit: 2899  
Confirmation No.: 4756  
January 30, 2004

Mail Stop Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Office Action mailed January 22, 2004, please amend the  
above-identified case as follows:

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

January 30, 2004

(Date of Deposit)

Alayne Geller

Alayne Geller

Alayne Geller

Signature

January 30, 2004

Date of Signature